Attorney Docket No. 0756-7733

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of: ) Koichiro TANAKA et al. ) Serial No. 10/582,616 ) Filed: June 12, 2006 ) For: LIGHT EXPOSURE APPARATUS ) AND MANUFACTURING METHOD ) OF SEMICONDUCTOR DEVICE ) USING THE SAME )

- ) Confirmation No. 2042
- ) Group Art Unit: 2823

) Examiner: George R. Fourson III

## AMENDMENT AND RESPONSE TO RESTRICTION/ELECTION REQUIREMENT

Honorable Commissioner of Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

Please consider the following amendments and remarks in connection with the above-identified application.

Amendments to the Claims are reflected in the listing of claims, which begins on page 2 of this paper.

**Remarks** begin on page 5 of this paper.